

372418



35.C11946

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

AKIRA FUNAKOSHI, ET AL.

Application No.: 08/801,464

Filed: February 18, 1997

For: SUBSTRATE CUTTING METHOD
AND SUBSTRATE CUTTING
APPARATUS

Examiner: C. Dexter

Group Art Unit: 3724

Date: January 14, 2000

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The Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

☒ An additional fee is required.

The fee has been calculated as shown below:

CLAIMS AS AMENDED						
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NO. PREVIOUSLY PAID FOR	PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL CLAIMS	34	MINUS	22	= 12	x \$9 \$18	\$ 216.00
INDEP. CLAIMS	6	MINUS	6	= 0	x \$39 \$78	\$ 00.00
Fee for Multiple Dependent claims \$130°/\$260						-
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT						\$ 216.00

- ☐ °Verified Statement claiming small entity status is enclosed, if not filed previously.
- ☒ A check in the amount of \$216.00 is enclosed.
- ☐ Charge \$_____ to Deposit Account No. 06-1205. A duplicate of this sheet is enclosed.
- ☒ Any prior general authorization to charge an issue fee under 37 CFR 1.18 to Deposit Account No. 06-1205 is hereby revoked. The Assistant Commissioner is hereby authorized to charge any additional fees under 37 CFR 1.16 and 1.17 which may be required during the entire pendency of this application, or to credit any overpayment, to Deposit Account No. 06-1205. A duplicate of this paper is enclosed.
- ☐ A check in the amount of _____ to cover the fee for a three month extension is enclosed.
- ☐ A check in the amount of \$_____ to cover the Information Disclosure Statement fee is enclosed.
- ☒ Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should be directed to our address given below.

Respectfully submitted,



Attorney for Applicants
Registration No. 33,326

FITZPATRICK, CELLA, HARPER & SCINTO
30 Rockefeller Plaza
New York, New York 10112-3801
Facsimile: (212) 218-2200
SEW\vjw

35.C11946

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

15/72
X. Cobb
1/29/00

In re Application of:)
: Examiner: C. Dexter
AKIRA FUNAKOSHI, ET AL.)
: Group Art Unit: 3724
Application No.: 08/801,464)
:
Filed: February 18, 1997)
:
For: SUBSTRATE CUTTING METHOD) January 14, 2000
AND SUBSTRATE CUTTING :
APPARATUS)

The Assistant Commissioner for Patents
Washington, D.C. 20231

AMENDMENT AND RESPONSE TO
NOTICE OF INFORMALITY

Sir:

In response to the Official Action dated December 14,
1999, please amend the above-identified application as follows:

IN THE CLAIMS:

Please amend claims 8 and 9 as follows:

01/18/2000 CVORACHA 00000108 08801464

01 FC:103

216.00 OP